

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/820,575  
Filing Date ..... April 7, 2004  
Inventor ..... Scott E. Moore et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2877  
Examiner ..... Roy Punnoose  
Attorney's Docket No. .... MI22-2493  
Title: Semiconductor Workpiece Processing Methods and Turbidity Monitoring Methods

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether all the submitted references are prior art.

Respectfully submitted,

Dated: 11/16/06By:   
James D. Shaurette  
Reg. No. 39,833

Sheet 1 of 1

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2493		SERIAL NO. 10/820,575	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Scott E. Moore et al.			
				FILING DATE April 7, 2004		GROUP 1734	
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	5,865,665	2/2/1999	Yueh			
	AB	5,207,921	5/4/1993	Vincent, John D.			
	AC	3,809,243	5/7/1974	Teters, Phillip J.			
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AQ						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes      No
	AR						
	AS						
	AV						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER				DATE CONSIDERED			
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>							